

First Named

Inventor : Roger L. Frick

Appln. No. : 10/822,425

Filed : April 12, 2004

Title : ELECTROMAGNETIC RESONANT SENSOR

Docket No. : E252.12-0008

Group Art Unit:

Examiner:

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450 I CERTIFY THAT THIS PAPER IS BEING SENT BY U.S. MAIL, FIRST CLASS, TO THE ASSISTANT COMMISSIONER FOR PATENTS, ALEXANDRIA, VA 22313, THIS _____ DAY OF

7777

PATENT ATTORNEY

Sir:

The enclosed PTO Form-1449 lists patents and publications submitted pursuant to 37 C.F.R. 1.97. Copies of the patents or publications are enclosed as necessary [if application filing date is after June 30, 2003, copies of U.S. patents and application publications are not required].

This application relies, under 35 U.S.C. 120, on the earlier filing date of prior Application No., filed on _. The following references, listed on the enclosed PTO Form 1449 were submitted to and/or cited by the Office in the prior application; therefore, under 37 C.F.R. 1.98(d), copies are not required to be provided herewith:

Submitted herewith is a copy (with English translation as appropriate) of an Official Search Report of the _ Patent Office in counterpart foreign Application No. _ filed _.

The following foreign language documents and English language documents are believed to be equivalent or substantially equivalent:

FOREIGN LANGUAGE

ENGLISH LANGUAGE

TIME OF FILING

The Information Disclosure Statement is being filed:

with the application or within three months of the filing date of a national application (other than a continued prosecution application under 37 C.F.R. 1.53(d)) or date of entry into the national stage of an international application or, to the best of the undersigned's knowledge, before the mailing date of a first Office action on the merits or a first office action after the filing of a request for

continued examination under 37 C.F.R. 1.114, whichever event occurs last. In accordance with 37 C.F.R. 1.97(b), no certification or fee is required.

2. _ after the time period specified in paragraph 1 above, but, to the best of the undersigned's knowledge, before the mailing date of a final action under 37 C.F.R. 1.113 or notice of allowance under 37 C.F.R. 1.311, or an action that otherwise closes prosecution of the application. In accordance with 37 C.F.R. 1.97(c), submitted herewith is:

(check either A or B below)

- A. _ a statement as specified in 37 C.F.R. 1.97(e), no fee is required.
- B. _ the fee set forth in 37 C.F.R. 1.17(p) for submission of an Information Disclosure Statement under 37 C.F.R. 1.97(c).
- after the mailing date of either a final action under 37 C.F.R. 1.113 or a Notice of Allowance under 37 C.F.R. 1.311, whichever occurs first, but on or before payment of the issue fee. Applicant petitions for consideration of this Information Disclosure Statement pursuant to 37 C.F.R. 1.97(d)(2). Applicant submits herewith:
 - A. a statement as specified in 37 C.F.R. 1.97(e); and
 - B. the fee set forth in 37 C.F.R. 1.17(p).

Respectfully submitted,

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FORM PTO-1449	Atty. Docket No.: E252.12-0006	Application No.: 10/822,425
PE CLIST OF PATENTS AND PUBLICATIONS FOR	First Named Inventor: Roger L. Frick	
APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Filing Date: April 12, 2004	Group Art:

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